## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:	)
Shinji MAEKAWA	) Confirmation No. 4975
Application No. 10/573,328	) Group Art Unit: 2815
Filed: March 24, 2006	) Examiner: Anthony Ho
For: MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE	)

## **PETITION TO WITHDRAW FROM ISSUE**

MAIL STOP 313(c)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Applicant hereby petitions for the withdrawal of this application from issue. The issue fee for this case was paid on September 25, 2009.

The reason for withdrawal from issue of this application is for consideration on the merits of a Request for Continued Examination and Information Disclosure Statement, filed herewith in the application.

The Commissioner is authorized to charge the Petition Fee of \$130.00 or any deficiencies or credit any overpayment to Deposit Account No. 19-2380.

Respectfully submitted,

By: /Jeffrey L. Costellia, Reg. No. 35, 483/ Jeffrey L. Costellia

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